

JUN 21 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

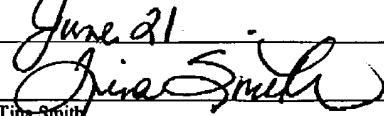
OFFICIAL

In re the application of: Smith *et al.* Docket: TI-22782B
Appl. No.: 09/757,073 Examiner: E. Cameron
Filed: 1/8/01 Art Unit: 1762
For: Polyol-Based Method For Forming Thin Film Aerogels On Semiconductor Substrates

REPLY PURSUANT TO 37 C.F.R. § 1.111

June 18, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FACSIMILE CERTIFICATE	
I hereby certify that this correspondence is being transmitted by Facsimile to the Patent and Trademark Office in accordance with 37 C.F.R. §1.6d on	
 June 21, 2004. Tina Smith	

Examiner:

In response to the Office Action dated April 19, 2004, please amend the above-identified patent application as follows:

IN THE SPECIFICATION

In the paragraph added on page 1, before line 1, replace the paragraph with

This application is a continuation of U.S. application number 09/115,854 filed 07/15/98—
now patent 6,171,645—, which is a continuation of U.S. application number 08/748,926 filed
11/14/96—now patent 5,807,607—, which claims priority from provisional application numbers:
60/006,852 filed 11/16/1995, 60/006,853 filed 11/16/1995, 60/012,764 filed 3/4/1996, 60/012,800
filed 3/4/1996, and 60/014,005 filed 3/4/1996.